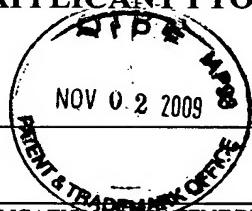


<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449</b>	Docket No. <b>52433/803</b>	Application No. <b>10/540,418</b>
	Applicant(s) <b>Riki OKAMOTO et al.</b>	Examiner <b>Deborah Yee</b>
	Filing Date <b>June 24, 2005</b>	Confirmation No. <b>9229</b>
		Art Unit <b>1793</b>

**U. S. PATENT DOCUMENTS**

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE*

**FOREIGN PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
	6-33140	02/08/1994	JP			Abstract and partial English translation	
	4-88125	03/23/1992	JP			Abstract	
	3-180426	08/06/1991	JP			Abstract	
	6-172924	06/21/1994	JP			Abstract and partial English translation	
	7-11382	01/13/1995	JP			Abstract and partial English translation	
	6-200351	07/19/1994	JP			Abstract and partial English translation	
	6-293910	10/21/1994	JP			Abstract and partial English translation	
	6-128688	05/10/1994	JP			Abstract and partial English translation	
	2000-319756	11/21/2000	JP			Abstract and partial English translation	

**OTHER DOCUMENTS**

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.

EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	